Application/Control No. Applicant(s)/Patent Under Reexamination 09/751,877 YEN ET AL. Notice of References Cited Examiner Art Unit Page 1 of 1 Cybille Delacroix-Muirheid 1614 **U.S. PATENT DOCUMENTS** Document Number Date Name Classification Country Code-Number-Kind Code MM-YYYY US-2004/0023860 02-2004 Α Yen et al. 514/12 US-В С US-US-D US-Ε F US-US-G US-Н US-1 US-J Κ US-L US-US-**FOREIGN PATENT DOCUMENTS** Document Number Date Country Classification Name Country Code-Number-Kind Code MM-YYYY Ν 0 Р Q R S Т **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) U ٧ W

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